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CONFIRMATION NO. 5976

Bib Data Sheet

SERIAL NUMBER 09/905,662	FILING DATE 07/13/2001 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. 09792909-5081
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** CONTINUING DATA *MK (Verified)*

** FOREIGN APPLICATIONS *MK (Verified)*
 JAPAN P2000-214974 07/14/2000
 JAPAN P2000-240134 08/08/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 08/27/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	Initials <i>MK</i>		

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TITLE
 Substrate cleaning method and substrate cleaning apparatus

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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